

In re Application of:

TOSHIMA, et al.

Serial No.: 10/052,534

Filed: January 23, 2002

For: Substrate Processing Apparatus and

SUBSTRATE PROCESSING METHOD

Art Unit: 1746

Examiner: Kornakov, Michail

Atty. Dckt: 033082M115

PETITION FOR A THREE-MONTH EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

This is a Petition for Extension of Time for a three month period. This Petition for Extension of Time is being concurrently filed with a Response.

A check in the amount of \$1020.00 is enclosed.

Respectfully submitted, SMITH, GAMBRELL & RUSSELL, LLP

Michael A. Makuch Reg. No. 32,263

Date: April 27, 2006

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